

JG17 Rec'd PTO 28 MAR 2005

INFORMATION DISCLOSURE STATEMENT BY APPLICANTS PTO FORM 1449	Atty. Docket No. 10191/3447	Serial No. 10/529420 To Be Assigned
	Applicant(s) LAMMEL et al.	
	Filing Date Herewith	Group To Be Assigned

U. S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
AA	5,882,496*	Mar. 16, 1999	YU et al.			
	6,139,758*	Oct. 31, 2000	Xiangzheng TU			

* Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
						YES	NO
AA	96 39632*	Dec. 12, 1996	PCT				
	02 02458*	Jan. 10, 2002	PCT				

* Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

OTHER DOCUMENTS

EXAMINER'S INITIALS	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.	
AA	Henmi et al., <i>Vacuum Packaging for Microsensors by Glass-Silicon Anodic Bonding</i> , Sensors and Actuators, Lausanne, Switzerland, May 1, 1994, Vol. A43, No. 1/3, pgs. 243-48.*	

* Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

EXAMINER	<i>[Signature]</i>	DATE CONSIDERED 1-2-07
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		